

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Andrej S. MITROVIC

SERIAL NO: 10/673,501

GAU: 2128

FILED: September 30, 2003

EXAMINER: Akash Saxena

FOR: SYSTEM AND METHOD FOR USING FIRST-PRINCIPLES SIMULATION TO CHARACTERIZE A SEMICONDUCTOR MANUFACTURING PROCESS

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

Applicant(s) wish to disclose the following information.

REFERENCES

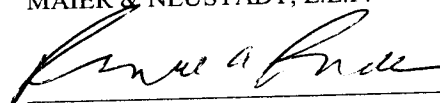
- ☒ The applicant wishes to make of record the reference(s) listed on the attached form PTO-1449 and/or accompanying documents from a corresponding foreign application. Copies of the listed references were made of record in co-pending application serial numbers 10/673,583, filed September 30, 2003, 10/673,507, filed September 30, 2003, 10/673,467, filed September 30, 2003, 10/673,138 filed September 30, 2003 and 10/673,506, filed September 30, 2003. Also submitted in co-pending application serial number 10/673,467 was a Chinese Office Action (with English translation) dated June 19, 2009 for the Examiner's consideration, the references therein were filed in Information Disclosure Statements on December 22, 2005 and January 12, 2006. Also submitted in co-pending application serial number 10/673,583 was a Chinese Office Action (with English translation) dated June 19, 2009 for the Examiner's consideration, the references therein were filed in Information Disclosure Statements on September 15, 2005 and September 22, 2005. Also submitted in co-pending application serial number 10/673,506 was a Chinese Office Action (with English translation) dated June 19, 2009 for the Examiner's consideration, the references therein were filed in Information Disclosure Statements on May 23, 2006 and January 12, 2006. Also submitted was a Chinese Office Action for serial number 10/673,507, the references cited therein were previously cited by the Examiner on October 5, 2006 and the second reference was filed on December 22, 2005. Also submitted was a Chinese Office Action for co-pending application serial number 10/673,507 dated June 19, 2009. Also submitted was a Chinese Office Action for co-pending application number 10/673,583. The references cited therein were previously filed in an Information Disclosure Statement filed on September 15, 2005. Copies of the listed reference(s) are attached, where required, as are either statements of relevancy or any readily available partial or full English translations of pertinent portions of any non-English language reference(s).
- ☐ Credit card payment is being made online (if electronically filed), or is attached hereto (if paper filed), in the amount required under 37 CFR §1.17(p).

DEPOSIT ACCOUNT

- ☒ Please charge any additional fees for the papers being filed herewith and for which no payment is enclosed herewith, or credit any overpayment to deposit account number 15-0030.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, L.L.P.



Steven P. Weihrouch

Registration No. 32,829

Ronald A. Rudder, Ph.D.

Registration No. 45,618

Customer Number  
22850  
Tel. (703) 413-3000  
Fax. (703) 413-2220  
(OSMMN 02/10)